

13, 14, 17-20. For the Examiner's convenience, a clean copy of all remaining amended and pending claims is presented below.

[Please cancel Claim 1 without prejudice or disclaimer.]

*Sub C1*

*multilayer*

*Sub E2*

*multilayer*

2. The semiconductor chip package of claim 3, wherein the solder film includes one selected from a group consisting of Pb, Sn, Ag, In, and Bi.
3. A semiconductor chip package comprising:  
a substrate having a plurality of bonding pads;  
a semiconductor chip having a plurality of conductive bumps on a front side thereof, the conductive bumps contacting the bonding pads;  
a heat slug bonded to a backside of the semiconductor chip; and  
a solder film directly attached to the heat slug thereby bonding the heat slug to the backside of the semiconductor chip, wherein the backside of the semiconductor chip includes a metal layer formed thereon for strengthening adhesion between the semiconductor chip and the solder film.
4. The semiconductor chip package of claim 3 wherein the metal layer is a multi-layered film selected from a group consisting of VNi/Au, Ti/VNi/Au, Cr/VNi/Au, Ti/Pt/Au, Cr/CrCu/(Cu)/Au, TiW/(Cu, NiV)/Au, VNi/Pd, Ti/VNi/Pd, Cr/VNi/Pd, Ti/Pt/Pd, Cr/CrCu/(Cu)/Pd and TiW/(Cu, NiV)/Pd.
5. The semiconductor chip package of claim 3, wherein a space between the semiconductor chip and the substrate is filled with an underfilling material.
6. The semiconductor chip package of claim 3, wherein the solder film has a size equal to or larger than a size of the semiconductor chip.
7. The semiconductor chip package of claim 3, wherein the heat slug is formed of a material selected from a group consisting of Cu, Al, and CuW.
8. The semiconductor chip package of claim 3, wherein the heat slug comprises an adhesion layer formed on a surface of the heat slug that contacts the solder film.
9. The semiconductor chip package of claim 8, wherein the adhesion layer is a

layer selected from a group consisting of a Ni/Au layer, a Ag layer, and a Pd layer,

10. The semiconductor chip package of claim 3, wherein the heat slug is coated with an anodizing layer on a surface of the heat slug that is opposite to another surface of the heat slug, on which the semiconductor chip is bonded.

11. The semiconductor chip package of claim 3, wherein the heat slug is shaped such that a portion of the heat slug is attached to the substrate by an adhesive.

12. The semiconductor chip package of claim 11, wherein the adhesive includes silicon rubber or elastomer.

13. The semiconductor chip package of claim 3, wherein a plurality of throughholes are formed on the heat slug.

14. A method of fabricating a semiconductor chip package, comprising:  
preparing the semiconductor chip having a plurality of conductive bumps on a front surface of the semiconductor chip and a metal layer on a backside of the semiconductor chip;  
bonding a heat slug on the backside of the semiconductor chip using a solder film; and  
attaching the semiconductor chip on a substrate such that the conductive bumps of the semiconductor chip contact a plurality of bonding pads on the substrate wherein the metal layer on the backside of the semiconductor chip strengthens adhesion between the semiconductor chip and the solder film.

15. The method of claim 14, further comprising filling a resin into a space between the semiconductor chip and the substrate.

[Please cancel Claim 16 without prejudice or disclaimer.]

17. The semiconductor chip package of claim 19, wherein the solder film has a size equal to or larger than a size of the semiconductor chip.

18. The semiconductor chip package of claim 19, wherein the heat slug is formed of a material selected from a group consisting of Cu, Al, and CuW.

*Mbd*

*C1 Mat*

*Sub Eg*

19. A semiconductor chip package comprising:  
a substrate having a plurality of bonding pads;  
a semiconductor chip having a plurality of conductive bumps on a front side thereof,  
the conductive bumps contacting the bonding pads;  
a heat slug bonded to the semiconductor chip, the heat slug comprising a top portion,  
side standing portions bent from the top portions, and side end portions bent again from the  
side standing portions; and  
a solder film that bonds the heat slug to the backside of the semiconductor chip  
wherein the top portion of the heat slug contacts the conductive solder film and the side end  
portions of the heat slug are attached to the substrate by an adhesive, and wherein the heat  
slug comprises an adhesion layer formed on a surface of the heat slug that contacts the solder  
film.

20. The semiconductor chip package of claim 19, wherein the heat slug is coated  
with an anodizing layer on a surface of the heat slug that is opposite to another surface of the  
heat slug, on which the semiconductor chip is bonded.